## Notice of References Cited Application/Control No. 10/038,697 Examiner Ricardo Pizarro Applicant(s)/Patent Under Reexamination BEN-ZE'EV ET AL. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,687,757	02-2004	Ben-Ze'ev et al.	709/250
	В	US-6,516,952	02-2003	Wang et al.	209/227
,	С	US-5,553,061	09-1996	Waggener et al.	250/491.1
	D	US-6,816,940	11-2004	Brooks et al.	710/308
	E	US-2003/0050055	03-2003	Ting et al.	455/419
	F	US-6,345,310	02-2002	Allison et al.	709/250
	G	US-6,438,135	08-2002	Tzeng, Shrjie	370/412
	Н	US-6,789,056	09-2004	Vinnakota et al.	703/22
		US-2005/0105556	05-2005	Joung et al.	370/469
	J	US-2003/0210702	11-2003	Kendall, Chad William	370/401
	к	US-2003/0053481	03-2003	Abiru et al.	370/465
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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	R					
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## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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